

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re the application of:

Hidehiko KIRA et al.

Serial Number: 08/897,953

Filed: July 24, 1997

For: METHOD AND SYSTEM FOR FABRICATING SEMICONDUCTOR DEVICE



Group Art Unit: 2814

Examiner: David E. GRAYBILL

#31/Reg.
Est. Time

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PETITION FOR EXTENSION OF TIME

Assistant Commissioner of Patents
Washington, D.C. 20231

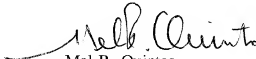
Date: January 6, 1999

Sir:

Applicants petition the Commissioner of Patents and Trademarks to extend the time for response to the Office Action dated July 6, 1998 for the third month from December 6, 1998 to January 6, 1999.

Attached please find a check in the amount of Four Hundred Ninety Dollars (\$490.00) (calculated as \$870.00 minus \$380.00 for the second month extension of time filed on December 7, 1998) to cover the cost of the extension. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340. This paper is filed in triplicate.

Respectfully submitted,
ARMSTRONG, WESTERMAN, HATTORI
McLELAND & NAUGHTON


Mel R. Quintos
Attorney for Applicants
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Enclosure: Fee (Check)

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490.00 DP
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